

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	)	
Kenro NAKAMURA, et al.	)	Group Art Unit: 1765
	)	
Application No. 09/453,831	)	Examiner: Umez-Eronini, Lynette T.
	)	
Filed: December 2, 1999	)	Confirmation No. 3119
	)	
For: POLISHING METHOD AND	)	
POLISHING LIQUID	)	

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AFTER DECISION ON APPEAL**

After the Decision on Appeal of the Board of Patent Appeals and Interferences dated September 28, 2007, Applicants file this Amendment to place the application in condition for allowance, in accordance with the provisions discussed in M.P.E.P. § 1214.07. Accordingly, Applicants respectfully request that the application be amended as follows:

**Amendments to the Claims** are reflected in the listing of claims beginning on page 2 of this paper.

**Remarks** begin on page 4 of this paper.